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CofL

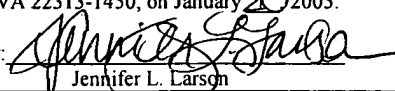
PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No.: 6,806,198 Docket: AMDA.497PA
Issue Date: October 19, 2004 Patentee: RING et al.
Title: GAS-ASSISTED ETCH WITH OXYGEN

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 20, 2005.

By:


Jennifer L. Larson

REQUEST FOR CERTIFICATE OF CORRECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate
FEB 03 2005
of Correction

Sir:

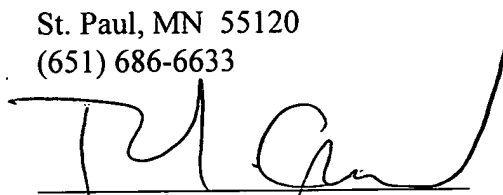
It is requested that a Certificate of Correction be issued correcting printing errors appearing in the above-identified United States patent. Two copies of the text of the Certificate in the suggested form are enclosed.

- ☐ As some of the errors listed are due to Applicant's mistake, please charge Deposit Account No. 01-0365 (AMDA.497PA/TT4168) in the amount of \$100.00 to cover the Certificate fee.
- ☒ As none of the errors listed is due to Applicant's mistake, no fee is necessary in connection with this Certificate.

Issuance of the Certificate of Correction should not expand or contract the scope of the claims as allowed per the Supplemental Notice of Allowability dated July 27, 2004, and re-examination should not be required.

Respectfully submitted,

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A handwritten signature in black ink, appearing to read 'R. J. Crawford', is written over a horizontal line.

Name: Robert J. Crawford
Reg. No.: 32,122

**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**

PATENT NO. : 6,806,198

PAGE 1 **of** 1

DATED : October 19, 2004

INVENTOR(S) : RING et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

In the Claims

Col. 5, line 43, Claim 1: "copper" should read - - copper, - -.

Col. 6, claims 22 and 23 are missing:

- - 22. The method of claim 1, further including analyzing the die after supplying sufficient oxygen-containing gas to the die. - -.
- - 23. The method of claim 22, further including obtaining results in response to analyzing the die, and using the obtained results to manufacture additional semiconductor devices. - -.

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PATENT NO. 6,806,198

Docket No. AMDA.497PA

1.1 FEB 2005